DECLARATION AND POWER OF ATTORNEY FOR U.S. PATENT APPLICATION

(X) Original	() Supplemental	() Substitute	() PCT	() DESIGN	
As a below named inventor next to my name; that I verily belies original, first and joint inventor (if patent is sought on the invention ent	ve that I am the original inventors are na	nal, first and sol	e inventor (if	only one name is list	ed below) or an
Title: METHOD FOR FORMING O	GAS CLUSTER AND	METHOD FOR	FORMING	THIN FILM	
of which is described and claimed in (X) the attached specification, or () the specification in the application and with amendments through () the specification in International (if applications)	n Serial No (if ap	plicable), or			amended on
I hereby state that I have reviewed amended by any amendment(s) refer acknowledge my duty to disclose is	rred to above.				
accordance with Title 37, Code of I					
I hereby claim foreign priority bene of any foreign application(s) for p application for patent or inventor's	atent or inventor's c	ertificate listed	below and hi	ave also identified be	clow any foreign
COUNTRY	APPLICAT	ION NO.	DA	TE OF FILING	PRIORITY

COUNTRY	APPLICATION NO.	DATE OF FILING	PRIORITY CLAIMED
Japan Japan	121983/1995	May 19, 1995	Yes
Japan Japan	244957/1995	September 22, 1995	Yes
Japan	064861/1996	March 21, 1996	Yes
	 		

I hereby claim the benefit under Title 35, United States Code §120 of any United States application(s) listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States application in the manner provided by the first paragraph of Title 35, United States Code §112, I acknowledge the duty to disclose material information as defined in Title 37, Code of Federal Regulations, §1.56(a) which occurred between the filing date of the prior application and the national or PCT international filing date of this application:

APPLICATION SERIAL NO.	U.S. FILING DATE	STATUS: PATENTED, PENDING, ABANDONED

And I hereby appoint V. M. Creedon, Reg. No. 17,111; John T. Miller, Reg. No. 21,120; John T. Fedigan, Reg. No. 24,347; Michael R. Davis, Reg. No. 25,134; Matthew M. Jacob, Reg. No. 25,154; Jeffrey Nolton, Reg. No. 25,408; Warren M. Cheek, Jr., Reg. No. 33,367; and Adam C. Volentine, Reg. No. 33,289, who together constitute the firm of WENDEROTH, LIND & PONACK, jointly and severally, attorneys to prosecute this application and to transact all business in the U.S. Patent and Trademark Office connected therewith.

I hereby authorize the U.S. attorneys named herein to accept and follow instructions from <u>NISHIZAWA & ASSOCIATES</u> as to any action to be taken in the U.S. Patent and Trademark Office regarding this application without direct communication between the U.S. attorneys and myself. In the event of a change in the persons from whom instructions may be taken, the U.S. attorneys named herein will be so notified by me.

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I further declare that all statements made herein of my own knowledge are true, and that all statements on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

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The above application may be more particularly identified as follows:

U.S. Ameliantian Curial Ma-	r	::::	Data	
U.S. Application Serial No.	r	gruur	Date_	

Applicant Reference Number 96-F-008US Atty Docket No. 653/95F008US

Title of Invention METHOD FOR FORMING GAS CLUSTER AND METHOD FOR FORMING THIN FILM